Alain Billard

List of Publications by Year in descending order

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Version: 2024-02-01

1478505 1474206 9 273 6 9 citations h-index g-index papers 9 9 9 187 citing authors docs citations times ranked all docs

#	Article	IF	CITATIONS
1	Feasibility Synthesis and Characterization of Gadolinia Doped Ceria Coatings Obtained by Cathodic Arc Evaporation. Nanomaterials, 2021, 11, 1211.	4.1	1
2	DLC-Based Coatings Obtained by Low-Frequency Plasma-Enhanced Chemical Vapor Deposition (LFPECVD) in Cyclohexane, Principle and Examples. Coatings, 2021, 11, 1225.	2.6	7
3	Special Issue "Magnetron Sputtering Deposited Thin Films and Its Applications― Coatings, 2020, 10, 1072.	2.6	4
4	Mechanical properties, thermal stability and oxidation resistance of HfC/a-C:H films deposited by HiPIMS. Journal of Alloys and Compounds, 2020, 847, 156538.	5.5	10
5	The Structure, Morphology, and Mechanical Properties of Ta-Hf-C Coatings Deposited by Pulsed Direct Current Reactive Magnetron Sputtering. Coatings, 2020, 10, 212.	2.6	12
6	Pt–Ti Alloy Coatings Deposited by DC Magnetron Sputtering: A Potential Current Collector at High Temperature. Coatings, 2020, 10, 224.	2.6	3
7	Early studies on Cr-Coated Zircaloy-4 as enhanced accident tolerant nuclear fuel claddings for light water reactors. Journal of Nuclear Materials, 2019, 517, 268-285.	2.7	212
8	Ag composition gradient CuCr0.93Mg0.07O2/Ag/CuCr0.93Mg0.07O2 coatings with improved p-type optoelectronic performances. Journal of Materials Science, 2017, 52, 11537-11546.	3.7	14
9	Investigations of Apatite-Structure Coatings Deposited by Reactive Magnetron Sputtering Dedicated to IT-SOFC. Plasma Processes and Polymers, 2007, 4, S99-S103.	3.0	10